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Attorney Docket No. 0553-0109.04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| The Re Application of: |) |
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| Shunpei YAMAZAKI et al | I hereby certify that this correspondence is being deposited with the United States |
| Serial No.: 10/700,198 |) Postal Service as first class mail in an envelope addressed to: |
| Filed: November 3, 2003 | Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on <u>May 17</u> , 2006 |
| Art Unit: 2814 | Cristia M. Nall |
| Examiner: John C. Ingham | |
| For: SEMICONDUCTOR DEVICE AND | Date: May 17, 2006 |

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Pursuant to 37 CFR §1.98(a)(2)(i), copies of cited US patent and US patent application publications are not submitted herewith.

ENTRY AND CONSIDERATION OF INFORMATION DISCLOSURE STATEMENT

In accordance with 37 CFR §1.97(d), it is requested that this IDS be considered by the Patent Office as it is being filed before payment of the issue fee and is 1) accompanied by the following statement, and 2)the fee set forth in §1.17(p):

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Each item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

REFERENCES CITED HEREIN

The reference disclosed herewith was cited in a rejection dated March 8, 2006, in a counterpart Korean patent application.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure

of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

FEE

In accordance with §1.17(p), Applicants are submitting a check for \$180.00. If any further fee is required for this IDS, please charge our Deposit Account No. 50/1039.

CONCLUSION

Accordingly, it is respectfully requested that the Examiner now enter and consider this IDS.

Respectfully submitted,

Mark J. Murphy

Registration No.: 34,225

COOK, ALEX, McFARRON, MANZO, CUMMINGS & MEHLER, LTD. 200 West Adams Street Suite 2850 Chicago, Illinois 60606 (312) 236-8500

Customer no. 000026568



LIST OF PUBLICATIONS CITED BY APPLICANT

| Atty. Docket No. 0553-0109.04 | <u>Serial No.</u> 10/700,198 |
|---|---------------------------------|
| <u>Applicant</u> Shunpei YAMAZAKI et al | |
| Filing Date | Group 2814 |

US PATENT DOCUMENTS

| *EXAMINER INITIAL | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB- CLASS | FILING DATE |
|----------------------|--------------------|------|------|-------|---------------|----------------|
| | | | | ï | | |

FOREIGN PATENT DOCUMENTS

| DOCUMENT NUMBER | DATE | APPLICANT | English Abstract | English Trans. | FILING DATE |
|--------------------|----------|------------------------------------|---------------------|-------------------|----------------|
| EP 0 650 197 A2 | 04/26/95 | Semiconductor Energy Lab Co Ltd | | | 10/14/94 |

OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.